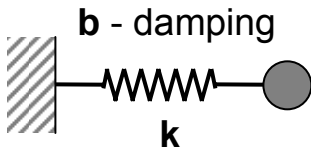


Notes for calculating and measuring thermomechanical noise

20.309

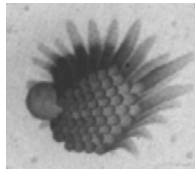
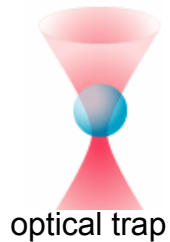
October 22, 2007



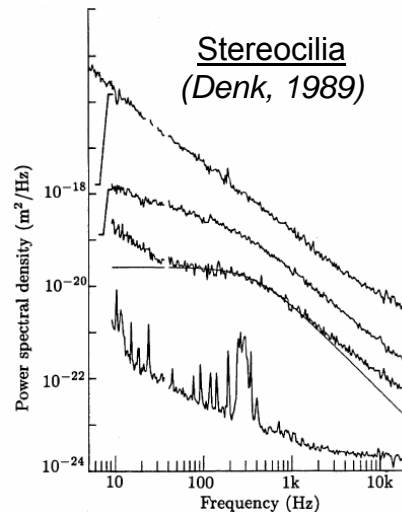
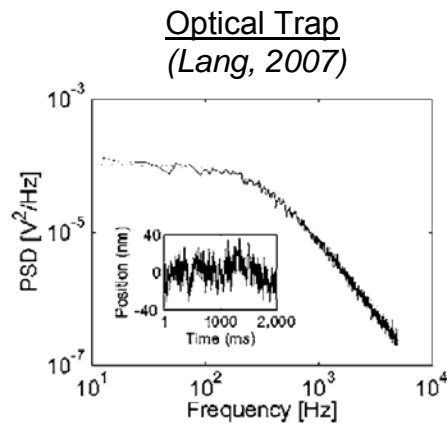
$$m\ddot{x} = -kx - b\dot{x} + F_d(t) \quad \text{where } F_d(t) \text{ is driving force}$$

Overdamped Oscillator

$$m\ddot{x} \ll kx \text{ and } b\dot{x}$$

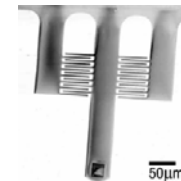


$$|H(\omega)| = (1 + \omega^2 \tau^2)^{-1/2} \quad \tau = b / k$$



Underdamped Oscillator

no approximation



AFM cantilever
(in air or vacuum)

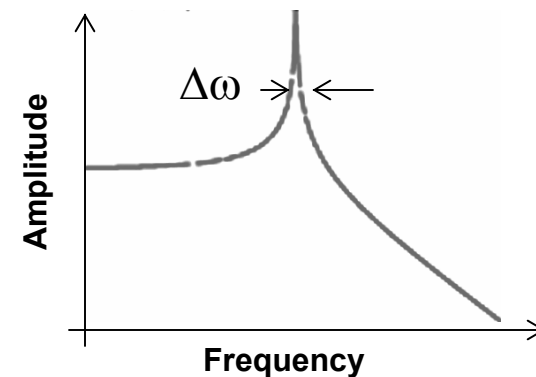
$$|H(\omega)| = Q m / k [Q^2(1 - \omega^2/\omega_o^2)^2 + \omega^2/\omega_o^2]^{-1/2}$$

Resonant Frequency

$$\omega_o^2 = k / m$$

Quality factor

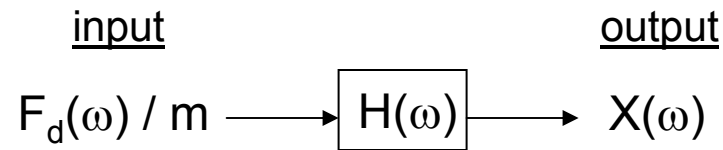
$$Q = \omega_o / \Delta\omega$$



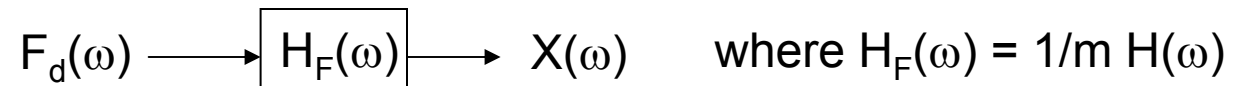
$$Q = \omega_o / 2\gamma$$

$$\gamma = b / 2m$$

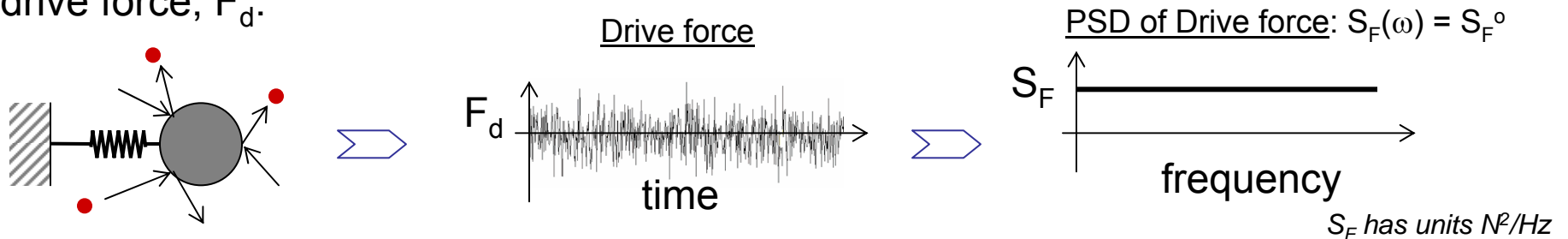
Recall from last time,



Redefine input (and transfer function),



Assume a series of microscopic impulse collisions create white noise fluctuations of drive force, F_d :



The response in position from driving force is:

$$X(\omega) = F_D(\omega) | H_F(\omega) |$$

If we square both sides, and divide by a long measurement time window, T

$$\lim_{T \rightarrow \infty} \left\{ (2/T) X^2(\omega) = F_D^2(\omega) |H_F(\omega)|^2 (2/T) \right\}$$

then we can express this in terms of the PSD,

$$S_x(\omega) = S_F(\omega) |H_F(\omega)|^2 \quad \text{Eq (1)}$$

In lecture, we found that $S_F(\omega) = S_F^0 = 4 k_b T k / (Q \omega_o)$ by using the Equipartition Theorem

$$\frac{1}{2} k_b T = \frac{1}{2} k \langle x^2 \rangle$$

and by using Parseval's Theorem which gave

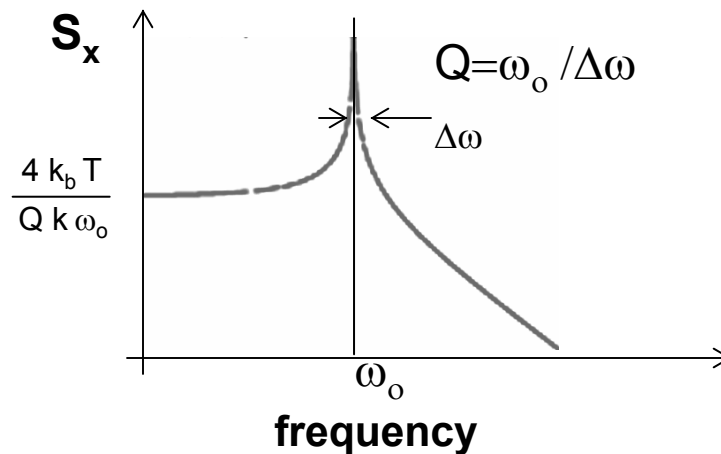
$$\langle x^2 \rangle = \int_0^{\infty} S(f) df$$

Thus, plugging in S_F and H_f into Eq (1) gives

$$S_x(\omega) = \frac{4 k_b T Q}{k \omega_o} [Q^2(1 - \omega^2/\omega_o^2)^2 + \omega^2/\omega_o^2]^{-1}$$

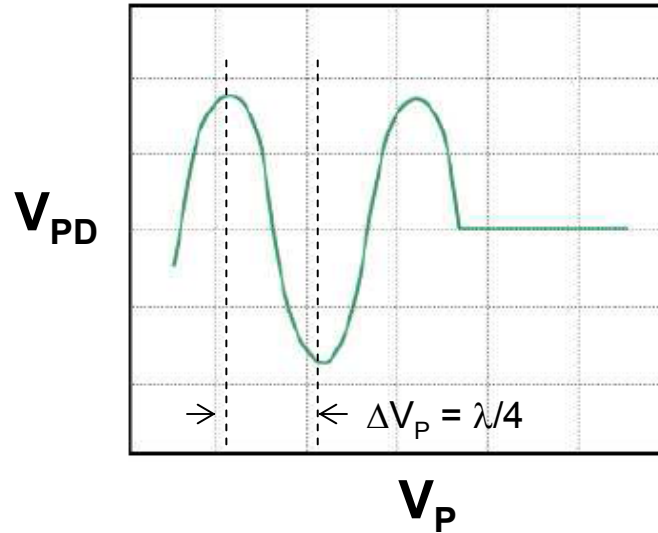
The thermal induced position noise, S_x , can be expressed as

$$S_x(\omega) = \underbrace{\frac{4 k_b T}{Q k \omega_o}}_{\text{Scale factor (y-intercept of PSD)}} \underbrace{\left[(1 - \omega^2 / \omega_o^2)^2 + \omega^2 / Q^2 \omega_o^2 \right]^{-1}}_{\text{Transfer Function, } |G(\omega)|^2 \text{ (p. 19 of Lab Module)}}$$



Calibrating the PSD measurement, Part I

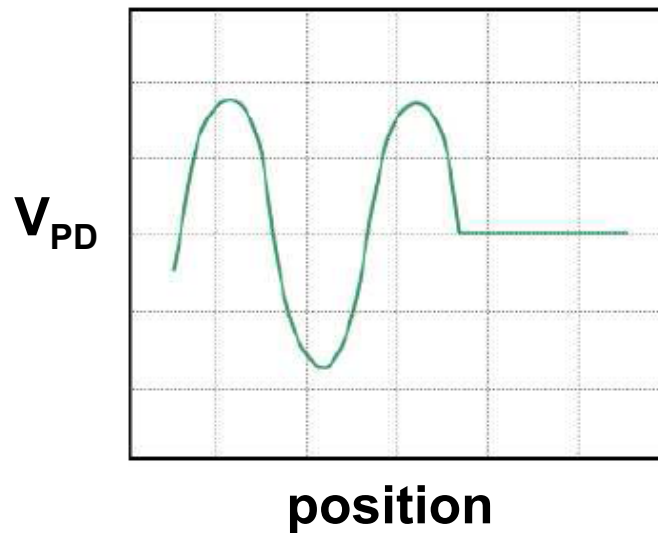
Measure force curve



V_P – voltage to piezo

V_{PD} – voltage from photodiode

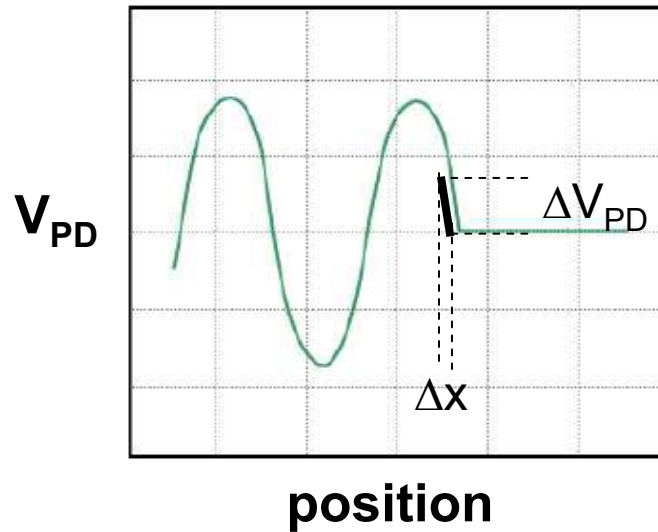
Convert **x-axis** to position by multiplying C_1



$$C_1 = \frac{\lambda/4}{\Delta V_P}$$

Calibrating the PSD measurement, Part II

Determine slope at contact point



$$C_2 = \frac{\Delta x}{\Delta V_{PD}}$$

Multiply PSD measurement by C_2

Note: Labview program acquires PSD in units of $V_{PD}/\sqrt{\text{Hz}}$

Minimum detectable force,

$$\langle F_{\min}^2 \rangle^{1/2} = \sqrt{S_F^0 B} = \sqrt{4 k_b T B k / Q \omega_0}$$

where bandwidth, $B = 1 / T_{\text{measure}}$

A sensitive force sensor has a low spring constant and high quality factor and resonant frequency